

<b>Notice of References Cited</b>	Application/Control No. 09/931,104	Applicant(s)/Patent Under Reexamination YOSHIDA, EIJI	
	Examiner Johannes P Mondt	Art Unit 2826	Page 1 of 1

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	D	US-			
	E	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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